

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No. 7846
Hideaki KUWABARA et al.)	Group Art Unit: 2826
Application No. 10/579,443)	Examiner: Scott R. Wilson
Filed: May 15, 2006)	
For: METHOD FOR FORMING LARGE AREA)	
DISPLAY WIRING BY DROPLET)	
DISCHARGE, AND METHOD FOR)	Date: <u>March 16, 2009</u>
MANUFACTURING ELECTRONIC DEVICE)	
AND SEMICONDUCTOR DEVICE (AS)	
AMENDED)		

RESPONSE TO NON-FINAL OFFICE ACTION

Mail Stop: AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 15, 2008, Applicants respectfully request reconsideration and allowance of the above-referenced application in view of the following amendments and remarks.